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PATENT
Docket No. JCLA12578
page 1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Application No. : 10/728,135
Filed : December 03,2003
For : IMMERSION LITHOGRAPHY PROCESS AND MASK LAYER
STRUCTURE APPLIED IN THE SAME
Examiner : CHACKO DAVIS, DABORAH
Art Unit : 1756

TRANSMITTAL SHEET

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in THIRTEEN (13) pages.

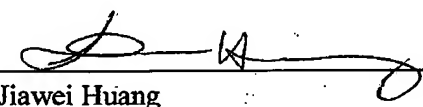
(X) An extension of time to respond for (1) month(s) is hereby requested.

Time Extension Fee:

- (X) One month (\$120 for Large Entity)
() Two months (\$450 for Large Entity)
() Three months (\$1020 for Large Entity)

(X) Commissioner is authorized to charge the one-month time extension fee in the amount of \$ 120 as calculated above or any other fees required in connection with the filing of this paper to Deposit Account No. 50-0710 (Order No. JCLA12578).

Date:

11/20/2006

Jiawei Huang
Registration No. 43,330

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